EL-PRESS

Digital Electronic Pressure Meters and Controllers

> Introduction

Bronkhorst High-Tech B.V. the European market leader in thermal Mass Flow Meters/Controllers and Electronic Pressure Controllers, has many years experience in designing and manufacturing precise and reliable measurement and control devices. With a wide range of instruments, Bronkhorst[®] offers innovative solutions for many different applications in many different markets.

The instruments are made to customers' specification, in various styles, suitable for use in laboratory, industrial and hazardous areas, in such diverse applications as semiconductor and analytical installations, to name but two.

> EL-PRESS series Pressure Meters and Controllers

The EL-PRESS series electronic Pressure Meters and Controllers have a well-proven compact thru-flow design and are available in pressure ranges from 2...100 mbar up to 8...400 bar, both in absolute and relative (gauge) pressure. A differential pressure transducer can also be supplied in the ranges of 2...100 mbar up to 0,3...15 bar. The pressure controller performs with high accuracy and repeatability and should be specified for forward or backward pressure control.

> State of the art digital design

Todays EL-PRESS series are equipped with a diaphragm type piezoresistive pressure sensor and a digital pc-board as standard and offer high accuracy, stability and reliability. The basic digital pc-board contains all of the general functions needed for measurement and control. In addition to the standard RS232 output, the instruments also offer analog I/O. As an option, an integrated inter-face board provides DeviceNet[™], PROFIBUS DP, Modbus, EtherCAT[®], PROFINET or FLOW-BUS protocols. The latter is a fieldbus based RS485, specifically designed by Bronkhorst High-Tech for their mass flow and pressure metering and control solutions, and with which the company already has over ten years of experience with digital communication.

> Pressure Controllers for every application

The control valve can be furnished as integral part of an EL-PRESS Pressure Controller (EPC), or as a separate component. It is a proportional, electromagnetic control valve with extremely fast and smooth control characteristics. With reference to the specific



field of application there are different series of control valves. There is a standard direct acting valve for common applications, a pilot operated valve for high flow rates, the so-called Vary-P valve that can cope with up to 400 bar ΔP and a bellows valve for applications with very low differential pressure.

> EL-PRESS features

- High accuracy and repeatability
- High pressure capability up to 400 bar
- Stable control even at varying process volumes
- Optional metal sealed and downported constructions
- Analog I/O signals: 0...5(10) V / 0(4)...20 mA
- Digital communication: RS232, DeviceNet[™], PROFIBUS DP, Modbus-RTU/ASCII, EtherCAT[®], PROFINET or FLOW-BUS

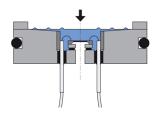
> Fields of application

- Semiconductor processing
- Gas and liquid chromatography
- Vapour pressure control in MOCVD processes
- Protective gas pressure control in extrusion moulding processes
- Autoclave / reactor pressure control



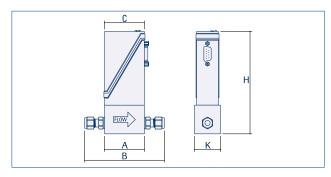
> Measuring principle

The Bronkhorst High-Tech EL-PRESS pressure sensor is a piezoresistive bridge on the surface of a silicon chip. This chip is drilled out on its reverse side, giving the inside of the chip the form of a pressure diaphragm, whose thickness determines the pressure range. When a pressure acts on this chip, the diaphragm flexes, and the resistor values of the bridge alter in proportion to the pressure. The measuring cell is separated from the external pressure by a thin, sensitive stainless steel diaphragm, and the sealed off cavity between diaphragm and cell is filled with oil.



Cross sectional drawing of a pressure sensor

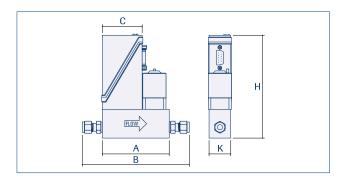
> Dimensional drawings



Pressure Meter

| Model | A | В | С | н | к | Weight (kg) |
|-----------------------------|----|-----|----|-----|----|-------------|
| P-502C/P-512C/P-522C/P-532C | 47 | 97 | 47 | 123 | 30 | 0,4 |
| P-502CM ¹⁾ | 87 | 124 | 47 | 128 | 29 | 0,6 |
| P-506C | 55 | 105 | 47 | 116 | 30 | 0,4 |

Dimensions in mm.



Forward Pressure Controller

| Model | Α | в | С | н | К | Weight (kg) |
|-----------------------|----|-----|----|-----|----|-------------|
| P-602CV/P-612CV | 77 | 127 | 47 | 123 | 25 | 0,7 |
| P-602CM ¹⁾ | 87 | 124 | 47 | 128 | 29 | 0,7 |
| Dimensions in mm. | | | | | | |

Back Pressure Controller

| Model | A | В | С | н | к | Weight (kg) |
|-----------------------|----|-----|----|-----|----|-------------|
| P-702CV/P-712CV | 77 | 127 | 47 | 123 | 25 | 0,7 |
| P-702CM ¹⁾ | 87 | 124 | 47 | 128 | 29 | 0,7 |

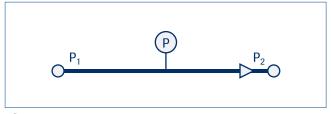
Dimensions in mm.

 $^{\scriptscriptstyle 1)}$ with $^{\scriptscriptstyle 1}\!/_4{}''$ face seal male connections

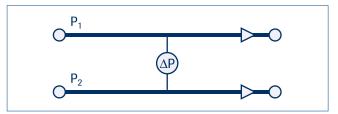


P-506C Differential Pressure Transducer

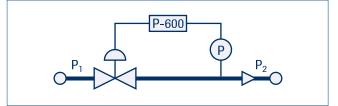
> Configurations



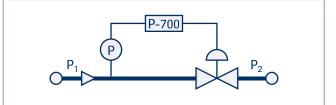
Pressure measurement



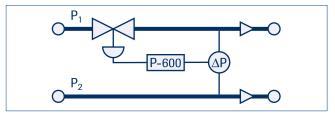
 $\Delta \mathbf{P} ext{-measurement}$



Forward pressure control



Back pressure control

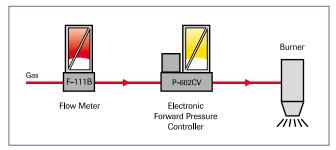


 ΔP -control

> Examples of some applications

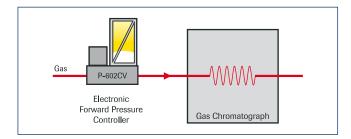
It is of course impossible to picture the possible number of applications. Here is a limited quantity of basic examples, which are often seen with some variations. However, identical or similar configurations are used in totally different applications. Therefore please consider the ones pictured here as examples for solving common applications.

> Pressure control combined with flow measurement



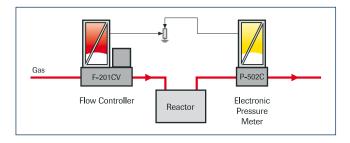
This arrangement of an EL-FLOW Mass Flow Meter with, in series, an EL-PRESS Forward Pressure Controller is used in burner test applications, or tests to check the inlet pressure dependence of the capacity of mechanical pressure regulators, or the tolerance on the bore of orifices, etc.

> Forward Pressure Control in G.C. (gas chromatography)



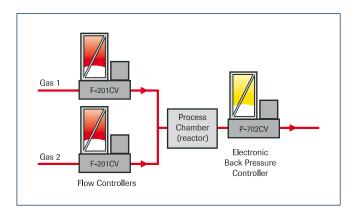
In Gas-Chromatography there is an increasing need to automate all required parameters. The EL-PRESS Forward Pressure Controller enables the user to select a desired pressure profile for the analyses, whereby the pressure is kept constant to a very precise value, even at very low flow rates.

> Pressure control with adjustable flow



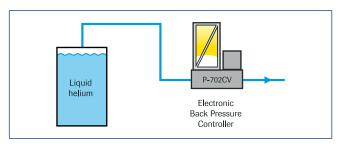
The control valve of the EL-FLOW F-201CV Mass Flow Controller (MFC) forms a closed loop pressure control system with the EL-PRESS P-502C Pressure Transducer: the Mass Flow Meter of the MFC measures the required flow rate to maintain the set pressure level. The setpoint voltage divider enables the user to adjust the maximum flow to build up desired pressure levels. Restriction of the maximum flow may for safety reasons be important in certain processes.

> Back pressure control independent of gas mix and total flow



A gas mixture is formed by EL-FLOW Mass Flow Controllers. In a process chamber the effect of the catalyst on certain reactions is tested. The pressure in the process chamber is controlled to the desired level by means of an EL-PRESS Back Pressure Controller, independent of the total flow and/or the composition of the mixture.

> Compensation of atmospheric pressure changes



Superconducting coils, which are used to generate magnetic fields, are cooled by liquid helium. Depending on the temperature exchange gaseous helium should be vented. With a manually controlled outlet the variation of the atmospheric pressure disturbs the magnetic field. By using an EL-PRESS P-702CV Back Pressure Controller the pressure for the superconducting coils is kept constant, thus eliminating the negative effects of atmospheric pressure variations.



> Technical specifications

Measurement / control system

| | -, |
|----------------------------------|---|
| Accuracy | : \pm 0,5% of full scale (FS) |
| (incl. linearity and hysteresis) | |
| Pressure rangeability | : Measurement: 1 : 50 (2100%) |
| | Control (with flow range 1 : 50) |
| | P-602CV/P-602CM/P-612CV 1 : 20 |
| | P-702CV/P-702CM/P-712CV 1:5 |
| Repeatability | : ≤ 0,1% RD |
| Response time sensor | : 2 msec |
| Control stability | : $\leq \pm 0,05\%$ FS (typical for 1 $\rm I_n/min~N_2$ |
| | at specified process volume) |
| Operating temperature | : -10+70°C |
| Temperature sensitivity | : 0,1% FS/°C |
| Leak integrity | : tested \leq 2 x 10 ⁻⁹ mbar l/s He |
| Attitude sensitivity | :<0,3 mbar (abs./rel. sensors); |
| (at 90° change) | < 6 mbar (dif. sensors) |
| Warm-up time | : negligible |
| | |

Mechanical parts

| Material (wetted parts) | : stainless steel 316L or comparable |
|------------------------------|--------------------------------------|
| Process connections | : compression type or face seal |
| | couplings |
| Seals | : standard: Viton® |
| | options: EPDM, FFKM (Kalrez®) |
| Ingress protection (housing) | : IP40 |

Electrical properties

| Power supply | | : +1524 Vdc | | |
|---|------------------------|-------------|-------------------|-------------------|
| Max. power consur | nption: | Supply | at voltage I/O | at current I/O |
| | Meter | : 15 V | 67 mA | 90 mA |
| | | 24 V | 49 mA | 67 mA |
| | Controller | : 15 V | 200 mA | 223 mA |
| | | 24 V | 132 mA | 150 mA |
| Extra for fieldbus: | PROFIBUS DP | : add 53 i | mA (at 15 V) or : | 30 mA (at 24 V) |
| (if applicable) | PROFINET | : add 77 r | nA (at 15 V) or 4 | 8 mA (at 24 V) |
| | EtherCAT [®] | : add 66 i | mA (at 15 V) or | 41 mA (at 24 V) |
| | DeviceNet [™] | : add 48 i | mA (at 24 V) | |
| Digital communication | tion | | | |
| Standard (9-pin | D-conn. male) | : RS232 | | |
| By optional inter | ace board | : PROFIBI | US DP, DeviceNe | et™, EtherCAT®, |
| | | FLOW-B | US, Modbus-RT | U/ASCII, PROFINET |
| Electrical connection | n | | | |
| Analog/RS232 | | : 9-pin D- | connector (male | e); |
| PROFIBUS DP | | : bus: 9-p | in D-connector | (female); |
| | | power: 9 | -pin D-connecto | or (male); |
| DeviceNet™ | | : 5-pin M | 12-connector (m | ale); |
| EtherCAT [®] /PROF | INET | : 2x RJ45 | modular jack (ir | n/out) |
| FLOW-BUS/Modbus-RTU/ASCII : RJ45 modular jack | | | | |

Technical specifications and dimensions subject to change without notice.

> Models and pressure ranges

Electronic Pressure Transducers (EPT)

| Models, elast. sealed | | Pressure ranges | Pressure ranges | | | | |
|-----------------------|---------------------|-----------------|-----------------|--|--|--|--|
| P-502C | (absolute/relative) | min. 2100 mbar | max. 1,2864 bar | | | | |
| P-512C | (absolute/relative) | | max. 2100 bar | | | | |
| P-522C | (absolute/relative) | | max. 4200 bar | | | | |
| P-532C | (absolute/relative) | | max. 8400 bar | | | | |
| P-506C | (differential) | min. 2100 mbar | max. 0,315 bar | | | | |
| | | | | | | | |

| Model, m | etal sealed | Pressure ranges | |
|----------|---------------------|-----------------|-----------------|
| P-502CM | (absolute/relative) | min. 7350 mbar | max. 1,2864 bar |

Electronic Pressure Controllers (EPC)

| Models, elast. sealed | | Pressure ranges (abs/rel) | | | | |
|-----------------------------|-----------------------|---------------------------|-----------------|--|--|--|
| P-602CV1) (forw | ard pressure control) | min. 5100 mbar | max. 3,264 bar | | | |
| P-612CV ¹⁾ (forw | ard pressure control) | | max. 5100 bar | | | |
| P-702CV1) (back | pressure control) | min. 20100 mbar | max. 12,864 bar | | | |
| P-712CV1) (back | pressure control) | | max. 20100 bar | | | |
| | | | | | | |

Models, metal sealed

P-602CM1) (forward pressure control) min. 17,5...350 mbar max. 3,2...64 bar P-702CM¹⁾ (back pressure control)

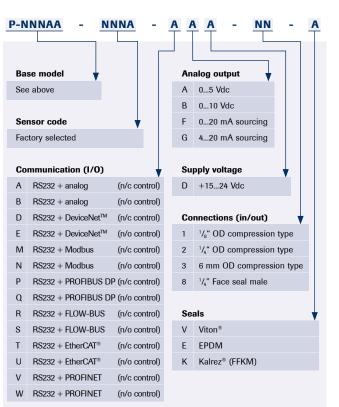
Pressure ranges (abs/rel)

min. 70...350 mbar max. 12,8...64 bar

1) Ky-max = 6.6 x 10^{-2}

For ranges of 200 or 400 bar rated pressure controllers and for low- ΔP control applications with Kv-values up to 1.0 please contact factory.

> Model number identification





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